

11/13/03

Patent Application
Docket No. JSF02-0004

Form PTO-1449 Modified List of Patents and Publications Cited by Applicant (Use several sheets if necessary)		Docket No.: JSF02-0004	Serial No.: 10/712, 196
U.S. Patent Department of Commerce Patent and Trademark Office		Applicant: Chang-Feng Wan	
		Filing Date: November 13, 2003	Group: 2811

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass
SFC	A-1	4,990,229	Campbell et al.	5-Feb-91		
	A-2	5,242,863	Xiang-Zheng et al.	7-Sep-93		
	A-3	5,397,962	Moslehi	14-Mar-95		
	A-4	5,448,068	Lee et al.	5-Sep-95		
	A-5	5,493,177	Muller et al.	20-Feb-96		
	A-6	5,550,090	Ristic et al.	27-Aug-96		
	A-7	5,801,383	Wada et al.	1-Sep-98		
	A-8	5,891,751	Kurtz et al.	6-Apr-99		
	A-9	5,921,461	Kennedy et al.	13-Jul-99		
	A-10	5,929,497	Chavan et al.	27-Jul-99		
	A-11	5,929,497	Chavan et al.	27-Jul-99		
	A-12	6,060,336	Wan	9-May-00		
	A-13	6,093,579	Sathe	25-Jul-00		
	A-14	6,117,787	Park	12-Sep-00		
	A-15	6,135,856	Tjaden et al.	24-Oct-00		
	A-16	6,258,223	Cheung et al.	10-Jul-01		
	A-17	6,262,417	Ju	17-Jul-01		
	A-18	6,284,149	Li et al.	4-Sep-01		
	A-19	6,294,425	Hideki	25-Sep-01		
	A-20	6,440,289	Woo et al.	27-Aug-02		
	A-21	6,534,850	Liebeskind	18-Mar-03		

<i>SR</i>	A-22	6,543,292	Colton et al.	8-Apr-03		
<i> </i>	A-23	6,543,292	Colton et al.	8-Apr-03		
<i> </i>	A-24	6,547,973	Field	15-Apr-03		
<i> </i>	A-25	6,593,242	Morgenstern	15-Jul-03		
<i> </i>	A-26	6,570,750 B1	Calcaterra et. al.	27-May-03		

OTHER DOCUMENTS

Examiner Initials		Author, Title, Date, Pertinent Pages, Etc.
<i>SR</i>	C-1	J. Yao et al. IEEE J. MEMS Vol. 8(2), 1999, pp. 129-134
<i> </i>	C-2	S. P. Pacheco et al. IEEE MTT-S Int. Microwave Symp. Dig., Boston, MA, June 2000, pp. 165-167.
<i> </i>	C-3	C.F. Wan, F.C. Suizbach, and J.D. Luttmmer, "TiNxOy transparent electrode material for HgCdTe infrared devices". J.Vac.Sci Technol. Vol. 10. No. 4. Jul/Aug 1992.
Date Examined:	Examiner:	<i>Sherry Lee</i>
5/10/05		

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U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass
<i>SR</i>	A-11	5,593,495	Jan. 14, 1997	Masuda et al.	117	4
<i> </i>	A-12	5,640,042	Jun. 17, 1997	Koscica et al.	257	595
<i> </i>	A-13	5,694,134	Dec. 2, 1997	Barnes	343	700
<i> </i>	A-14	5,886,867	Mar. 23, 1999	Chivukula et al.	361	311
<i> </i>	A-15	5,990,766	Nov. 23, 1999	Zhang et al.	333	205

<i>SL</i>	A-16	6,074,971	Jun. 13, 2000	Chiu et al.	501	139
	A-17	6,377,142 B1	Apr. 23, 2002	Chiu et al.	333	238
	A-18	6,525,630 B1	Feb. 25, 2003	Zhu et al.	333	205
	A-19	6,404,614 B1	Jun. 11, 2002	Zhu et al.	361	277
<i>V</i>	A-20	6,377,440 B1	Apr. 23, 2002	Zhu et al.	361	311

OTHER DOCUMENTS

Examiner Initials		Author, Title, Date, Pertinent Pages, Etc.
	C-4	
	C-5	
	C-6	
Date Examined:	Examiner:	<i>SL</i>
5/10/05		

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U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass
<i>SL</i>	A-21	6,492,883 B2	Dec. 10, 2002	Liang et al.	333	132
<i>S</i>	A-22	6,535,076 B2	Mar. 18, 2003	Partridge et al.	333	17.1
<i>S</i>	A-23	6,514,895 B1	Feb. 4, 2003	Chiu et al.	501	137
<i>S</i>	A-24	6,377,217 B1	Apr. 23, 2002	Zhu et al.	343	700
	A-25	5,486,491	Jan. 23, 1996	Sengupta et al.	501	137
<i>V</i>	A-26	6,556,102 B1	Apr. 29, 2003	Sengupta et al.	333	161

<i>SK</i>	A-27	6,590,468 B2	Jul. 8, 2003	du Toit et al.	333	17.3
<i>SK</i>	A-28	6,597,265 B2	Jul. 22, 2003	Liang et al.	333	204
	A-29					
	A-30					

OTHER DOCUMENTS

Examiner Initials		Author, Title, Date, Pertinent Pages, Etc.
	C-7	
	C-8	
	C-9	

Date Examined: *5/10/05* Examiner: *Shannon S. Lee*